

2834

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masuyuki KIKUSHIMA et al.

Application No.: 09/120,806

Filed: July 23, 1998

For: PIEZO-ELECTRIC RESONATOR AND MANUFACTURING METHOD THEREOF



Group Art Unit: 2834

Examiner: M. Budd

Docket No.: 101151

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated May 10, 2000, please amend the above identified application as follows:

IN THE DRAWINGS:

Please amend Figs. 1(b) and 11 as set forth in the attached Request for Approval of Drawing Corrections.

IN THE SPECIFICATION:

Page 7, line 10, after "1b." insert --The substrate 1b has a thickness b that is larger than the thickness a of the substrate 1a.--

REMARKS

Claims 1-6, 8, 10-13, 15-22 and 30-37 are pending. By this Amendment, the specification and Figs. 1(b) and 11 are amended to correct minor informalities pointed out by the Office Action. In particular, the specification and Figs. 1(b) and 11 are amended to further clarify, for example, that the substrate 1b has a larger thickness than that of the

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